

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		09/803,715	LI, JIA	
Examiner Julio J. Maldonado		Art Unit 2823	Page 1 of 1	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,169,792	12-1992	Katoh et al.	257/398
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	JP 63-271956	09-1998	JP	Hosaka	H 01L 21/76
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Silicon Processing for the VLSI Era, Volume 2, 1990 by Lattice Press, pages 38-41
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.